

Docket No.: 059516-0052



Corres. and Mail
BOX AF

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Zi-kui LIU, et al.

Application No.: 10/784,899

Filed: February 24, 2004

Group Art Unit: 1762

Title: BORIDE THIN FILMS ON SILICON

RESPONSE UNDER 37 C.F.R. 1.116
EXPEDITED PROCEDURE

Customer No.: 20277
Confirmation No.: 1022

Examiner: Brian K. Talbot

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action dated September 2, 2005. A Request for Reconsideration was previously submitted on December 30, 2005. Please amend the above-identified application as follows.